

Docket No.: 2336-255



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Seung Wan CHAE

U.S. Patent Application No. 10/812,015

Filed: March 30, 2004

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: Confirmation No.2799
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: Group Art Unit: 2811
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: Examiner: HUNG K VU

For: GALLIUM NITRIDE (GaN)-BASED SEMICONDUCTOR LIGHT EMITTING DIODE
AND METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of the first Office Action on the merits, but before the mailing date of the Final Rejection or Notice of Allowance. For the Examiner's information, the references listed on the attached PTO/SB/08A were cited in closely related Application No. 10/811,808.

08/01/2006 MBEYENE1 00000074 10812015

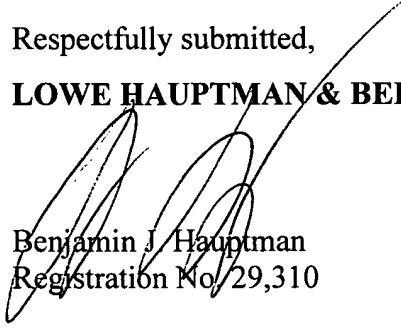
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180.00 OP

A credit card authorization form in the amount of \$180.00 is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No. 07-1337.

Respectfully submitted,

LOWE HAUPTMAN & BERNER, LLP



Benjamin J. Hauptman
Registration No. 29,310

1700 Diagonal Road, Suite 310
Alexandria, Virginia 22314
(703) 684-1111 BJH/ayw
Facsimile: (703) 518-5499
Date: July 28, 2006

GROUP
2811

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	Abstract	Translation	Equivalent
	10/173224	6/1998	Japan			
	09/129919	5/1997	Japan			
	10/173222	6/1998	Japan			
	2001-035796	2/2001	Japan			
	09-129933	5/1997	Japan			
	10-341039	12/1998	Japan			
	08-032115	2/1996	Japan			

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	Patent Abstracts of Japan – Publication No. 2001-035796, filed February 9, 2001	
EXAMINER	DATE CONSIDERED	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.